

2D NbOI₂: A Chiral Semiconductor with Highly In-Plane Anisotropic Electrical and Optical Properties

Yuqiang Fang, Fakun Wang, Ruiqi Wang, Tianyou Zhai,* and Fuqiang Huang*

Exploring in-plane anisotropic 2D materials is of great significance to the fundamental studies and further development of polarization-sensitive optoelectronics. Herein, chiral niobium oxide diiodide (NbOI₂) is introduced into the intriguing anisotropic 2D family with the experimental demonstration of anisotropic optical and electrical properties. 2D NbOI₂ crystals exhibit highly anisotropic dispersed band structures around the Fermi surface and strong in-plane anisotropy of phonon vibrations owing to the different bonding modes of Nb atoms along the *b*- and *c*-axes. Consequently, the anisotropic factors of optical absorbance and photoresponsivity in 2D NbOI₂ crystals reach up to 1.75 and 1.7, respectively. These anisotropic properties make 2D NbOI₂ an interesting platform for novel polarization-sensitive optoelectronic applications.

1. Introduction

2D layered materials with in-plane anisotropy have attracted tremendous research interests due to their highly anisotropic band structures, rich in-plane atomic arrangements and huge potentials in polarized optoelectronic applications.^[1–9] Compared with typical isotropic graphene, MoS₂, and MXenes,^[10–12] emerging anisotropic 2D materials such as black phosphorus,^[13–17] ReS₂,^[18–20] GeAs₂,^[21] and PdSe₂,^[22] show distinctive behavior in optical absorbance, electrical transports, and photodetection. On account of the unique anisotropic properties, such materials are designed as crystal orientation-

induced diodes,^[23,24] polarization-sensitive photodetectors,^[25,26] synaptic-neuromorphic devices,^[27] etc. Although the research on anisotropic 2D materials is progressing rapidly, it is still in its infancy as a whole. Therefore, developing new materials and exploring their anisotropic physical properties and functional devices are of great significance to the development of science and technology.

Recently, layered transition metal oxide dihalides MOX₂ (*M* = V, Nb, Ta, Mo; *X* = Cl, Br, I) have gained increasing attention among materials scientists due to their chiral crystal structure and unique physical properties.^[28–33] Among them, NbOI₂ has a low-symmetry monoclinic structure (space

group *C*2), in which Nb atoms shift away from the center of [NbO₂I₄] octahedra connected by sharing I–I edges and cornered O atoms along the *c*- and *b*-axes. Various connection modes enable NbOI₂ strong anisotropic physical properties and highly dispersed band structure. The simulated optical absorption coefficient along the *c*-axis (α_c) is an order of magnitude higher than that along the *b*-axis (α_b).^[34] Consequently, the NbOI₂ is expected to exhibit unique in-plane anisotropy. However, until now, the preparation and basic properties of 2D NbOI₂ crystals have not been thoroughly investigated, and in particular, the in-plane anisotropy caused by its low-symmetry structure is still unclear.

Here, we introduce a kind of transition metal oxide dihalides, NbOI₂, into the 2D materials family with experimental demonstration of strong in-plane anisotropy. Few-layer and monolayer NbOI₂ crystals were obtained through mechanical exfoliation, and these crystals showed large second harmonic generation (SHG) response, verifying its noncentrosymmetric crystal structure. The strong in-plane anisotropy of phonon vibration in 2D NbOI₂ crystals was observed by using angle-resolved polarized Raman measurements. The anisotropic electronic dispersion around the Fermi surfaces leads to the strong anisotropy of optical absorbance with an anisotropic factor of 1.75. In addition, highly anisotropic in-plane electrical resistance with a factor of 1.34 and photoresponsivity with a factor of 1.7 were demonstrated in 2D NbOI₂ crystals. These findings indicate that the 2D NbOI₂ crystal can serve as a promising candidate in anisotropic electronic and optoelectronic devices.

2. Results and Discussion

Bulk NbOI₂ belongs to the monoclinic space group *C*2 (No. 5) with *a* = 15.18 Å, *b* = 3.92 Å, *c* = 7.52 Å, β = 105.5°. Figure 1a

Dr. Y. Q. Fang, Prof. F. Q. Huang
State Key Laboratory of High-Performance Ceramics
and Superfine Microstructure
Shanghai Institute of Ceramics
Chinese Academy of Sciences
Shanghai 200050, P. R. China
E-mail: huangfq@mail.sic.ac.cn

F. K. Wang, Prof. T. Y. Zhai
State Key Laboratory of Materials Processing
and Die & Mould Technology
School of Materials Science and Engineering
Huazhong University of Science and Technology
Wuhan 430074, P. R. China
E-mail: zhaity@hust.edu.cn

Dr. R. Q. Wang, Prof. F. Q. Huang
State Key Laboratory of Rare Earth Materials Chemistry and Applications
College of Chemistry and Molecular Engineering
Peking University
Beijing 100871, P. R. China



The ORCID identification number(s) for the author(s) of this article can be found under <https://doi.org/10.1002/adma.202101505>.

DOI: 10.1002/adma.202101505

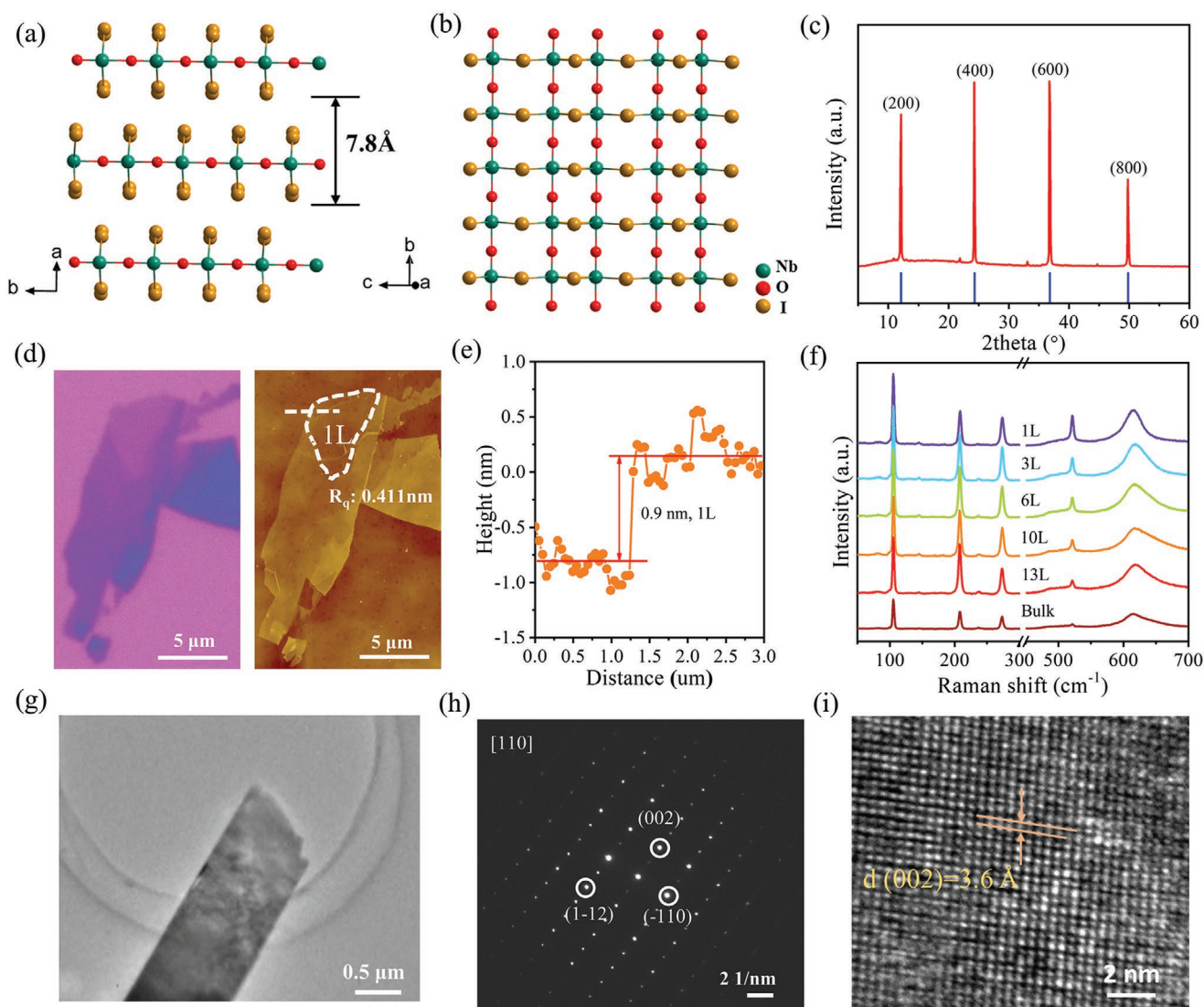


Figure 1. a,b) Schematic atomic structure of NbOI_2 with single layer of 7.8 Å from the c -axis and the a -axis. c) Powder X-ray pattern of the NbOI_2 crystals. d) OM and AFM images of as-exfoliated 2D NbOI_2 flake. e) The thickness of monolayer NbOI_2 . f) Raman spectra of 2D NbOI_2 flakes with different thicknesses. g) Low-magnification TEM image of a typical 2D NbOI_2 flake. h) SAED pattern of the 2D NbOI_2 flake in (g). i) Low-magnification TEM image of the 2D NbOI_2 flake in (g).

shows that NbOI_2 has a typical layered structure, in which monolayer NbOI_2 with a thickness of 7.8 Å. Nb and O atoms form a $[\text{NbO}]$ network grid, which is sandwiched by iodine layers. Similar to perovskite structure, NbOI_2 layers are constituted of $[\text{NbO}_2\text{I}_4]$ octahedra, which are connected by edge-sharing of I-I edges along the c -axis and by corner-sharing of O atoms along the b -axis. Nb atoms deviate from the center of $[\text{NbO}_2\text{I}_4]$ octahedra, forming Peierls distortion. The top view of monolayer NbOI_2 in Figure 1b shows rectangle network lattice. Figure S1a (Supporting Information) shows the shiny black NbOI_2 crystals, which were synthesized through self-vapor transport technology with Nb_2O_5 , Nb, and I_2 powders as precursors. The lateral size of the as-synthesized NbOI_2 crystals can be up to 5–10 mm. NbOI_2 crystals are very stable in atmosphere, which can be confirmed by the unchanged Raman spectra after several months (Figure S1b, Supporting Information).

The energy-dispersive X-ray spectroscopy spectrum (EDS) of NbOI_2 crystal shows a ratio of Nb, O, and I with 1:0.86:2, and elemental mapping demonstrates the uniformly distributed Nb, O, and I elements (Figure S1c–f, Supporting Information). The element fraction of oxygen deviates from 1, resulting from the inaccuracy of EDS for small atomic number. Figure 1c presents the powder X-ray diffraction of the as-synthesized NbOI_2 crystals. Four peaks including (200) peak at 12.1° , (400) peak at 24.3° , (600) peak at 36.8° , and (800) peak at 49.8° are confirmed, indicating the preferential growth orientation of NbOI_2 is (100) plane. The elemental binding energy of NbOI_2 crystals was examined by X-ray photoelectron spectroscopy (XPS). As shown in Figure S2a (Supporting Information), the two peaks located at 204.7 and 210.6 eV can be identified to Nb $3d_{5/2}$ and $3d_{3/2}$, the peaks at 620.2 and 631.3 eV belong to I $3d_{5/2}$ and $3d_{3/2}$, and the peak at 532.1 eV is the signal of O 1s.

Due to the weak interlayer van der Waals interaction, bulk NbOI₂ crystals can be peeled off several times with scotch tape. Then the exfoliated few-layer or monolayer flakes can be transferred onto the silica substrate using poly(dimethylsiloxane) (PDMS) film. Figure 1d shows the optical microscopy (OM) image and atomic force microscopy (AFM) image of mechanically exfoliated 2D NbOI₂ flakes on a silicon wafer with 300 nm oxidation layer. The 2D NbOI₂ flakes with different layers exhibit an optical contrast map depending on layer thickness. The lowest thickness of obtained NbOI₂ flakes is 0.9 nm, corresponding to monolayer (Figure 1e). Figure 1f shows Raman spectra of 2D NbOI₂ flakes with thickness ranging from bulk to 1 L. There exist five peaks (P₁–P₅ from low to high frequency) in the detecting Raman spectra range. These peaks barely changed with thickness, indicating the weak interlayer coupling of NbOI₂ layers. The low magnification transmission electron microscopy (TEM) image of as-exfoliated 2D NbOI₂ flake shows a long stripe with two parallel edges (Figure 1g), indicating a preferential cleaving orientation of NbOI₂ caused by its anisotropic crystal structure. Figure 1h shows the sharp selected-area electron diffraction (SAED) spots, reflecting the high crystallinity of as-exfoliated 2D NbOI₂ flake. The (–110), (1–12), and (002) planes are confirmed from the [110] zone axis. Subsequently, the high-resolution TEM was performed to examine the crystallinity and the relative orientation of as-exfoliated 2D NbOI₂ flakes. As shown in Figure 1i, the interplanar length vertical to the edge is 3.6 Å corresponding to the (002) plane, which indicates the long side direction is [002]. Hence, the preferential cleaving orientation of NbOI₂ crystals is the *c*-axis,

because the bonding interaction of Nb–I bonds along the *c*-axis is weaker than that of edge-sharing octahedron Nb–O bonds along the *b*-axis.

Raman spectrum contains abundant information of crystal structural orientation and phonon vibration. The phonon vibration of NbOI₂ should be anisotropic due to its noncentrosymmetric space group C2. Here, the angle-resolved polarized Raman spectroscopy (ARPRS) was performed to investigate the phonon vibrational anisotropy of NbOI₂. The polarized Raman scattering signals parallel and perpendicular to the polarized direction of the incident laser were collected through rotating a linear polarizer in front of the Raman detector. Figure S3 (Supporting Information) shows the Raman spectra of a 2D NbOI₂ flake measured in the parallel and perpendicular polarization configuration. The Raman modes P₁, P₂, P₃, P₅, and P₄ demonstrate A_g-like and B_g-like vibrations, respectively. Figure 2a,b presents the false-color image of the normalized polarized Raman peak intensities with the rotation angle from 0° to 360°. As shown in Figure 2a, P₁, P₂, P₃, and P₅ peaks exhibit 2-lobed shape and P₄ shows 4-lobed shape in parallel polarization configuration. While all peaks exhibit 4-lobed shape in perpendicular polarization configuration (Figure 2b). These results truly indicate that the polarized Raman intensities of NbOI₂ are dependent on the crystal structural orientation.

The intensity of Raman modes can be described by the equation $I \propto |e_i \mathbf{R} e_s|^2$,^[35,36] in which *e_i*, *e_s*, and **R** represent the polarization vectors of incident light, scattered light, and the Raman tensor, respectively. The unit polarization vector is *e_i* = (0, cos θ, sin θ), in which θ is the angle between the incident light and the

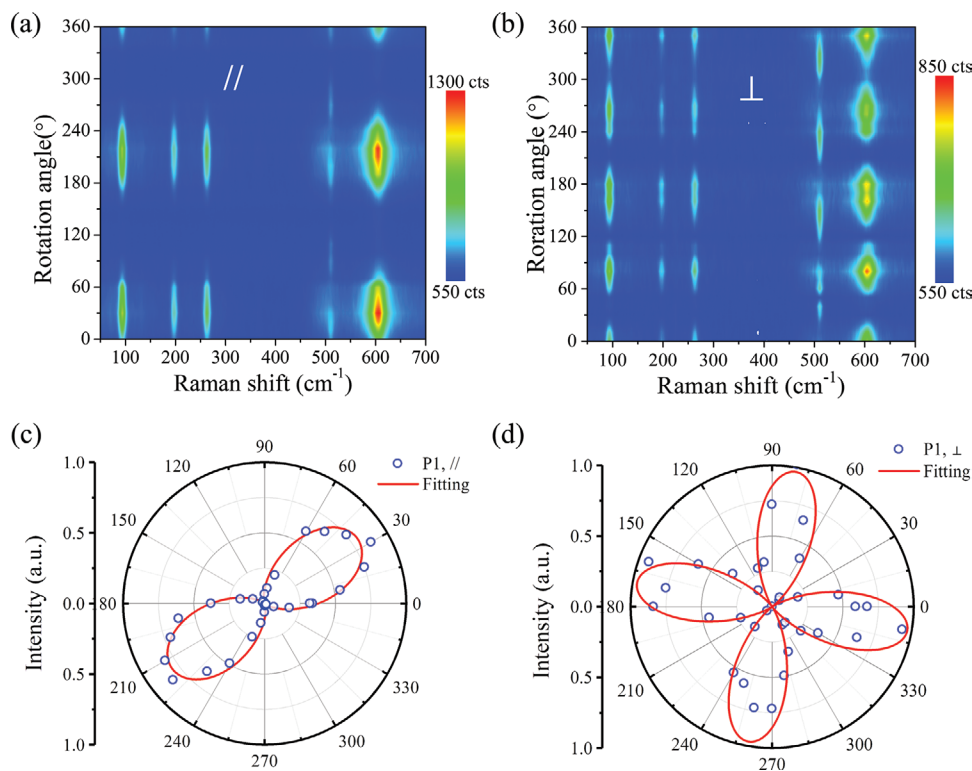


Figure 2. a,b) False-color plot of polarized Raman intensities for a 2D NbOI₂ flake measured in parallel and perpendicular polarization configurations. c,d) Polar plots of the measured and fitted Raman peak intensities of the P₁ peak in parallel and perpendicular polarization configurations.

b -axis of the measured 2D NbOI₂ flake, while e_s can be described as $e_s = (0, \cos\theta, \sin\theta)$ and $e_s = (0, -\sin\theta, \cos\theta)$ in the parallel and perpendicular configurations, respectively. Since NbOI₂ crystalizes in C2 space group, the Raman tensor can be written as

$$\mathbf{R}(A_g) = \begin{pmatrix} a & d & 0 \\ d & b & 0 \\ 0 & 0 & c \end{pmatrix} \quad (1)$$

$$\mathbf{R}(B_g) = \begin{pmatrix} 0 & 0 & e \\ 0 & 0 & f \\ e & f & 0 \end{pmatrix} \quad (2)$$

Hence, the anisotropy of Raman scattering intensities in the parallel and perpendicular polarization configurations can be expressed by the following equations^[37]

$$\mathbf{I}(A_{||}) \propto (b \cos\theta)^2 + (c \sin\theta)^2 \quad (3)$$

$$\mathbf{I}(B_{||}) \propto (\sin 2\theta)^2 \quad (4)$$

$$\mathbf{I}(A_{\perp}) \propto (\sin 2\theta)^2 \quad (5)$$

$$\mathbf{I}(B_{\perp}) \propto (\cos 2\theta)^2 \quad (6)$$

Figure 2c,d shows the polar plot of P₁ Raman position in parallel and perpendicular polarization configuration, in which the blue dots are experimental values and the red lines represent the fitting result based on the above equations. The other four peaks are summarized in Table S1 (Supporting Information). The A_g-like modes (P₁, P₂, P₃, and P₅) exhibit 2-lobed and 4-lobed shape in the parallel and perpendicular polarization configuration, respectively. The B_g-like mode P₄ shows 4-lobed formation under the parallel and perpendicular polarization configuration. Interestingly, the A_g-like modes show maximum intensities along the c -axis in the parallel configuration, which is helpful for us to judge the axial direction of the 2D NbOI₂ flakes.

In order to investigate the interlayer thermal expansion and atomic vibration of 2D NbOI₂ flake, the temperature-dependent Raman characterization was performed on the 2D NbOI₂ flake at temperatures from 80 to 300 K.^[38–41] As shown in Figure 3a, the intensity of observed Raman peaks increases with decreasing temperature owing to the enhanced anharmonic

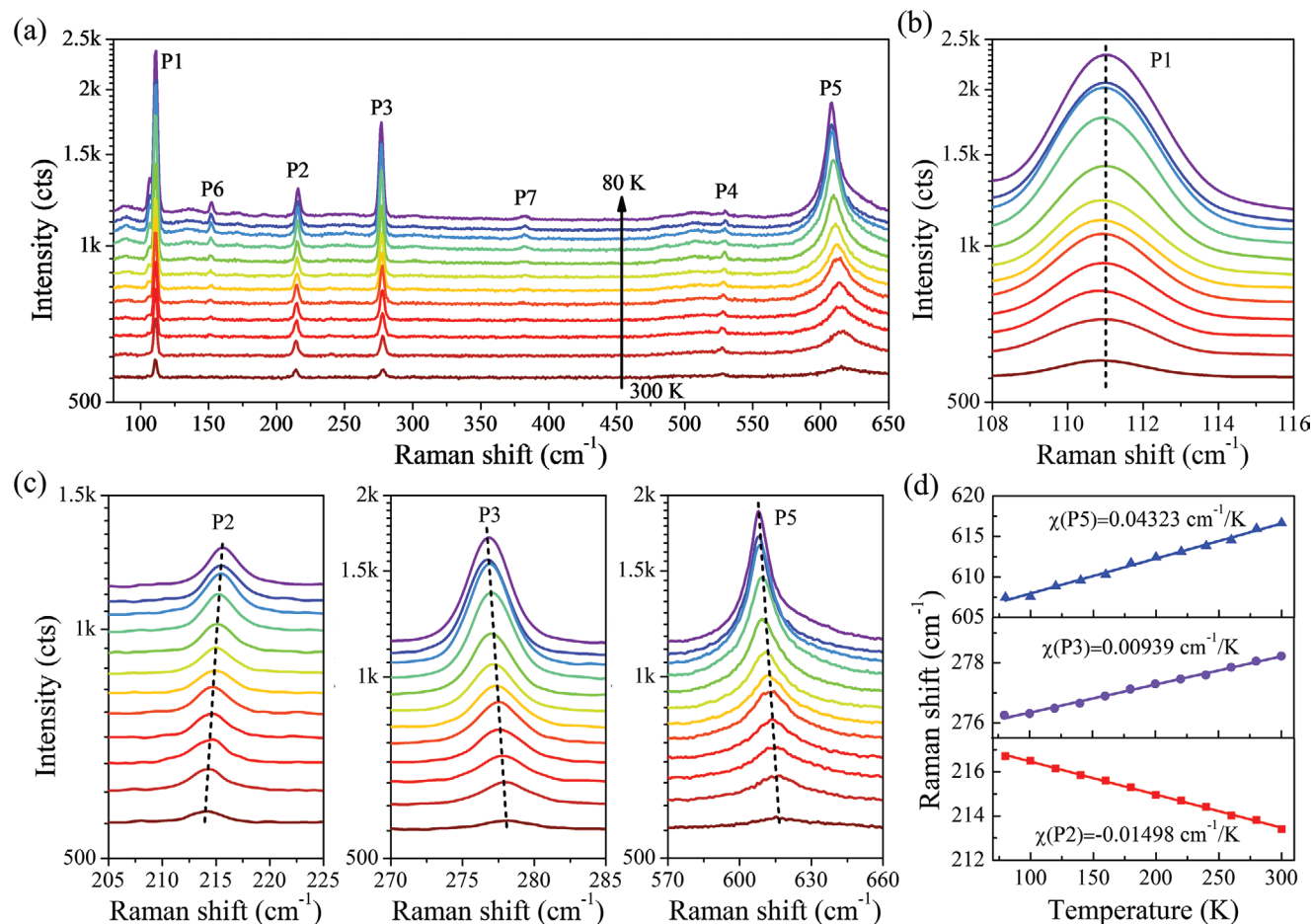


Figure 3. a) Raman spectra of 2D NbOI₂ flake measured at different temperature ranging from 80 to 300 K. b,c) The enlarged view of offset in the P₁–P₅ peaks at different temperature. d) Raman peak positions of P₂, P₃, and P₅ as a function of temperature.

coupling of A_g and B_g modes at higher temperature. Such coupling interaction would costume energy and decrease the thermal vibrational excitation. Figure 3b,c shows the movement of Raman peaks at temperature from 80 to 300 K. The P_1 and P_4 peaks do not shift with decreasing temperature, P_2 exhibits a redshift with decreasing temperature, which results from anharmonic lattice vibrations at higher temperature. Figure 3c presents the typical plots for Raman peak positions as a function of temperature. The temperature dependence of peak positions can be fitted by linear equation of $\omega(T) = \omega_0 + \chi(T)$, where ω_0 presents the Raman peak position at 0 K and χ is the slope of the fitted line, also indicating the first-order temperature coefficient of the related Raman modes. The χ values of P_2 , P_3 , and P_5 are calculated to be 0.01498, 0.00939, and 0.04323 $\text{cm}^{-1} \text{K}^{-1}$, respectively. The P_5 Raman mode is the most sensitive to the temperature among these three peaks. The temperature coefficient χ of NbOI_2 is bigger than that of SnSe_2 , RhI_3 , and graphene.^[42] The value of the first-order temperature coefficient of Raman modes is proportional to the interlayer forces in the layered materials. Hence, NbOI_2 has stronger interlayer interaction than graphene.

Nonlinear optical effect is one of the most important properties in investigating the noncentrosymmetric materials. Since NbOI_2 belongs to C_2 space group with broken inversion symmetry, SHG was measured on a 2D NbOI_2 flake to investigate the related nonlinear optical phenomena. **Figure 4a** shows the strong SHG response of a 2D NbOI_2 flake under various excitation wavelengths ranging from 800 to 1300 nm. This wavelength

response region makes NbOI_2 crystals a potential application in infrared nonlinear optics. **Figure 4b** presents power dependence of SHG intensities under excitation with a wavelength of 800 nm. The wavelength of the generated laser is 400 nm, which is a half of the incident wavelength. **Figure 4c** displays the SHG intensities in logarithmic coordinate as a function of excitation power. The slope of the fitted plot is 1.8, which is close to the theoretically calculated value of 2, indicating that the collected signals stem from the contribution of SHG. In order to calculate the value of SHG conversion efficiency η of NbOI_2 flakes, monolayer MoS_2 was employed as a reference. The SHG intensities of monolayer MoS_2 and 2D NbOI_2 flake are shown in **Figure 4d**. The refractive index of NbOI_2 is 2.6 at 1200 nm and 2.2 at 600 nm (**Figure 4e**). The SHG efficiency of NbOI_2 is calculated to be $191\eta_{\text{MoS}_2}$ ($\approx 19.1\%$), by comparing the coefficients of NbOI_2 flake and monolayer MoS_2 in the equation $\eta = P_{2\omega}/P_{\omega} = [8\pi^2 d^2 (\chi^{(2)})^2 P_{\omega}] / [n_{\omega}^2 n_{2\omega} \lambda \omega^2 c \epsilon_0]$.^[43] To detect the crystal symmetry of NbOI_2 , the polarization resolved SHG measurements were performed with the emission field parallel to the excitation field. **Figure 4f** displays two asymmetric lobes, resulting from the chiral symmetric space group C_2 of NbOI_2 crystals. The chiral structure of NbOI_2 crystal was demonstrated by circular dichroism (CD) investigation (**Figure S4**, Supporting Information).

To determine the bandgaps of 2D NbOI_2 flakes with different thicknesses, the micro-optical absorption measurement was carried out in the wavelengths ranging from 300 to 900 nm. **Figure 5a** shows the absorption spectra of 2D NbOI_2

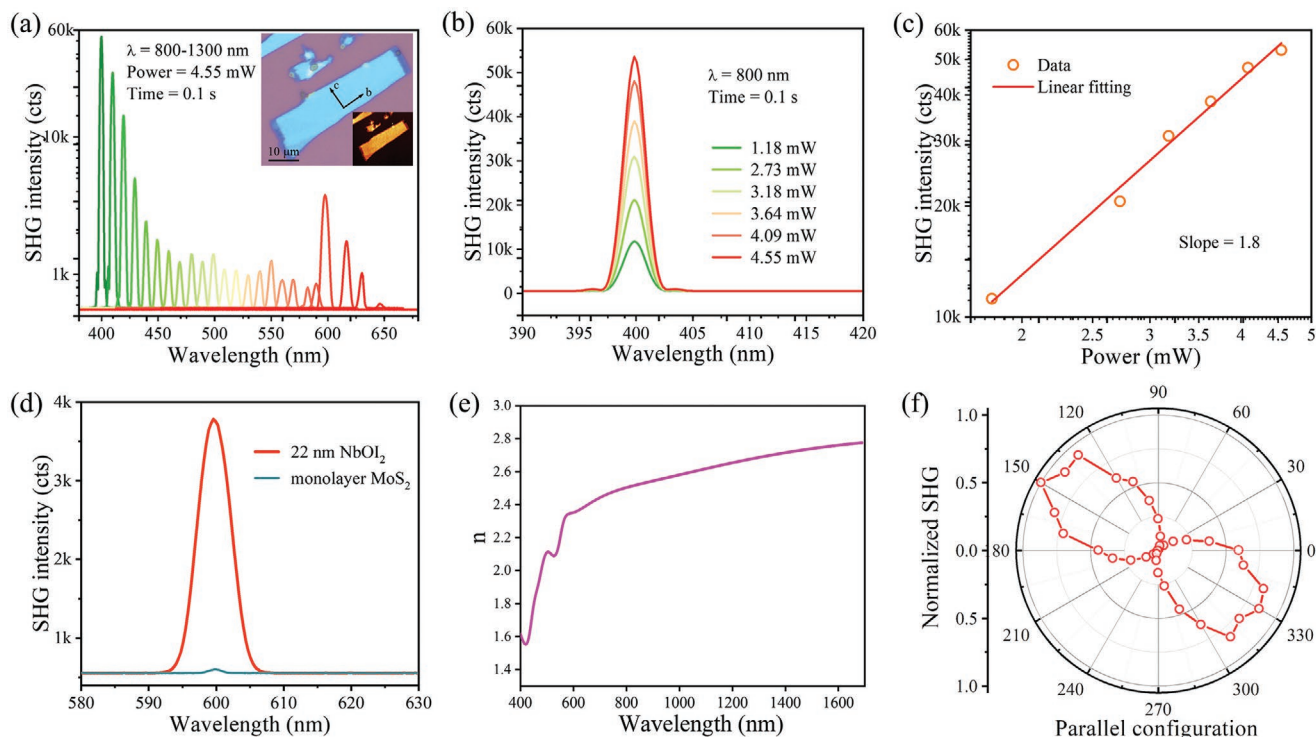


Figure 4. a) SHG signals of a 2D NbOI_2 flake under various excitation wavelengths ranging from 800 to 1300 nm. Inset: OM image of NbOI_2 flake. b) SHG spectra in the incident light of 800 nm with different powers from 1.18 to 4.55 mW. c) Power-dependent SHG intensities. d) The SHG intensities of a 22 nm NbOI_2 flake and monolayer MoS_2 . e) Refractive index of NbOI_2 at the wavelengths from 400 to 1700 nm. f) Polarization dependence of SHG intensity in parallel polarization configuration.

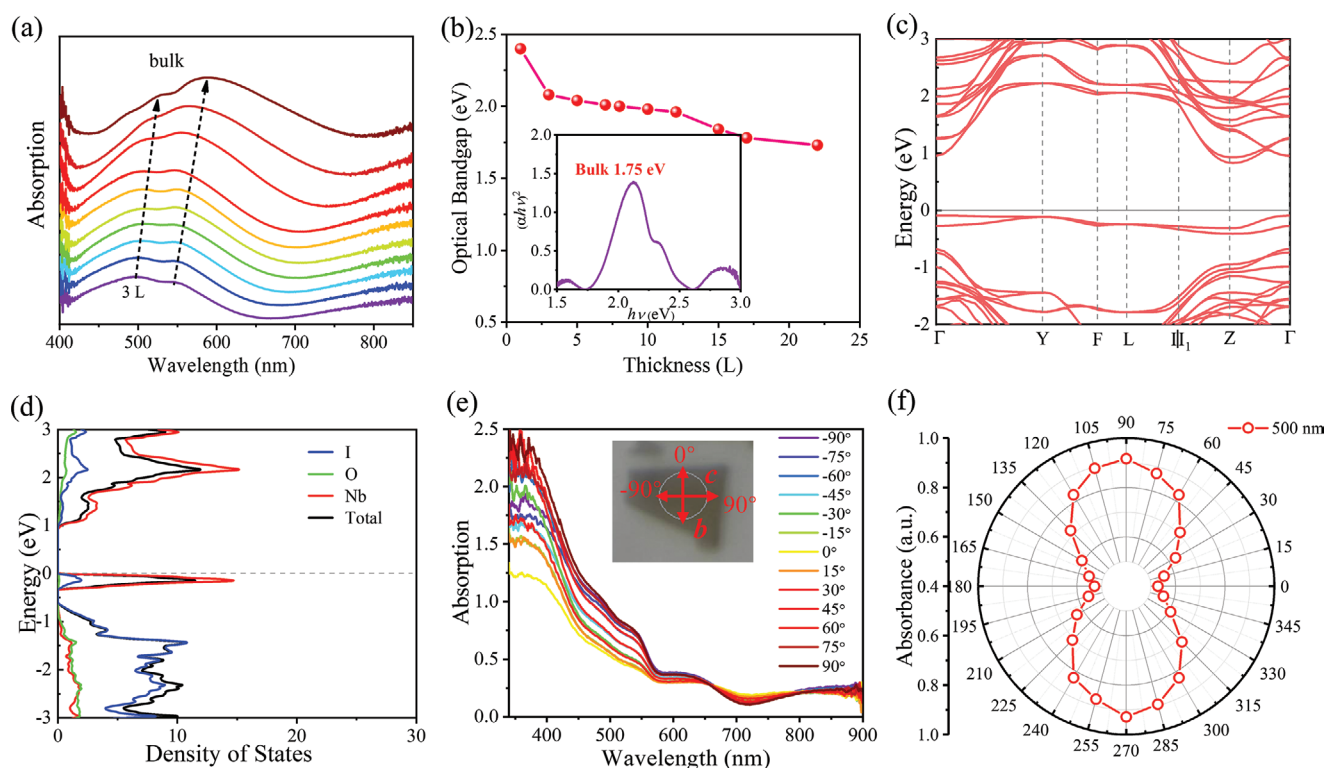


Figure 5. a) Optical absorption of 2D NbOI₂ flakes with different thicknesses. b) The thickness dependence of optical bandgaps of 2D NbOI₂ flakes. c,d) Calculated electronic band structure and density of state of bulk NbOI₂. e) Polarization-resolved absorption spectra of NbOI₂ crystal measured at the wavelength ranging from 300 to 900 nm. Inset: OM image of the sample. The measured angle rotates from -90° to 90° with steps of 15° . f) Polar plots of the absorption at wavelengths of 500 nm.

flakes with various thickness, which is confirmed by the AFM results (Figure S5, Supporting Information). The absorbance edges show a blueshift and the absorption intensities drop gradually with the decrease of thickness, suggesting the increasing bandgap resulting from quantum size effect. The specific bandgaps were determined from the spectra using Tauc plots, as presented in Figure S6 (Supporting Information). Figure 5b displays the thickness-dependent optical bandgaps of 2D NbOI₂ flakes, revealing the tunability of bandgap from 1.7 eV of bulk to 2.4 eV of monolayer. In addition, photoluminescence (PL) spectra of the 2D NbOI₂ flakes show prominent peaks at ≈ 2.25 eV (Figure S7, Supporting Information), which is in accordance with the optical bandgaps. The band structure and density of state of bulk NbOI₂ are calculated based on the DFT method (Figure 5c,d). The conduction band of NbOI₂ is mainly composed of the Nb-4d states, and the highest valence band below the Fermi level is mostly contributed by electrons from the I-5p and Nb-4d orbitals. Hence, the electron transition prefers to occur along the *c*-axis with I–I connection.

NbOI₂ reveals a great potential to detect polarized light signals owing to the in-plane anisotropic dispersed band structure. In order to understand the anisotropic features of the linear dichroism (LD) in 2D NbOI₂ flakes, the polarization-resolved absorption spectra were collected with polarization angle in steps of 15° , as shown in Figure 5e. The polar absorbance intensities were plotted at a wavelength of 500 nm (Figure 5f), showing a two-lobed shape, which is in accordance with the structural anisotropy. The corresponding anisotropic absorption

ratio at 500 nm is calculated to be 1.75, which is larger than 1.15 and 1.09 of 2D PdSe₂ and GeSe flakes.^[22,44] Interestingly, the dominating polarization orientation is along the *c*-axis in the visible range, while the polarization is along the *b*-axis in the near-infrared wavelength (Figure S8, Supporting Information). This phenomenon reveals that 2D NbOI₂ flakes exhibit wavelength-selective absorbance along various lattice axis.

Apart from anisotropic optical absorbance, the anisotropic electrical transport has been systematically studied. Figure 6a schematically illustrates the device with twelve electrodes in step of 30° , where the *b*-axis is defined as 0° . The optical image of the NbOI₂ device is shown in the inset of Figure 6a. The linear current-voltage curves at different angles reveal good Ohmic contact and the resistance of NbOI₂ is clearly angle-dependent. Figure 6c presents the angle-dependent resistance extracted from the data of Figure 6b. The anisotropic resistance ratio of the NbOI₂ device is about 1.34, slightly lower than 1.52, 1.41, and 1.8 of GeP, Ta₂NiS₅, and GeAs₂.^[21,45] The in-plane anisotropic resistance may result from the different electron-egativity between I and O atoms. The valence bands near the Fermi level of NbOI₂ are mainly composed of electrons from I-p orbitals. Additionally, the conduction and valence bands reveal anisotropic dispersion, and the valence and conduction bands around the Fermi surface are almost dispersed along the crystallographic *b*-axis.^[34] Therefore, the electrons would migrate more easily along the *b*-axis because there exist more electrons in this direction. According to the anisotropy in electrical transport of 2D NbOI₂ flake, angle-resolved electrical

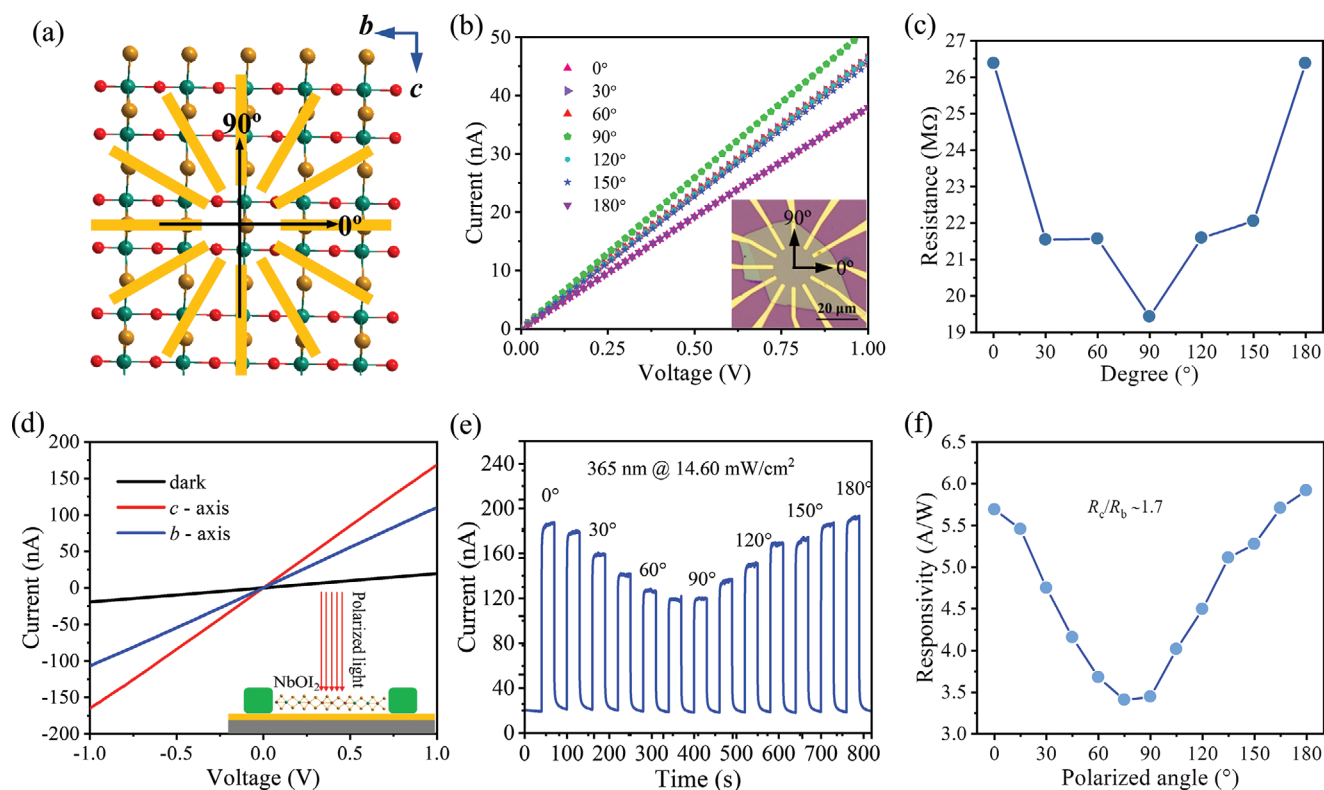


Figure 6. a) Schematic diagram of electrode structure with six pairs spaced at 30° apart. b) Current–voltage curves at different angles and the reference electrode along the *b*-axis as 0°. Inset: OM image of the NbOI₂ device with the labeled *b*- and *c*-axes. c) The angle-dependent resistance of 2D NbOI₂ flake. d) Typical current–voltage curves under dark and with light polarization orientation along the *b*- and *c*-axes. e,f) The measured photocurrent and responsivity and anisotropic factor at the angle ranging from 0° to 180° at the wavelength of 365 nm.

resistance measurements can be used to determine its in-plane structural orientation.

The strong in-plane anisotropy of electrical transport and LD conversion grant 2D NbOI₂ flake a potential application in polarization-sensitive photodetector. The OM and AFM images of 2D NbOI₂ flake reveal that the thickness of the device is 23 nm (Figure S9, Supporting Information). Figure 6d shows the typical current–voltage curves under dark and with polarized illumination along the *b*- and *c*-axes. It is obvious that the photoresponsivity at the *c*-axis is larger. The angle-resolved photoresponsivity measured at polarized angle from 0° to 180° indicates stronger On and Off current along the *c*-axis than the *b*-axis (Figure 6e). The polarized-angle-dependent responsivity is shown in Figure 6f. The value of R_c/R_b is 1.7 for the 2D NbOI₂ flake, which is comparable to 1.83, 2.2, 2.0, and 2.1 of 2D GeP, PdSe₂, GeAs₂, and GeS₂ flakes, respectively.^[46–48] After exposure to the atmosphere for four months, the in-plane anisotropic photoresponsivity of the device remains unchanged, indicating its long-term stability (Figure S10, Supporting Information). The anisotropy factor of photoresponsivity of 2D NbOI₂ flake is larger than that of resistance. Hence, the polarized photo-detection mainly results from the stronger optical absorption along the *c*-axis than the *b*-axis, which demonstrates that 2D NbOI₂ flake can be developed to be polarized optoelectronic devices. In addition, 2D NbOI₂ flake shows photoresponse at the wavelengths ranging from 300 to 700 nm (Figure S11, Supporting Information), demonstrating the potential application

of broadband photodetection. Figure S12 (Supporting Information) shows the current–voltage curves at various excitation intensities, the fitted photocurrent (*I*) and responsivity (*R*) as a function of power density follows a power law of $I \approx P^{0.54}$ and $R \approx P^{0.46}$. The low indexes result from the trap states produced by the defects of NbOI₂ device. In addition, the defect trap state leads to the long response time (3 s) and relaxation time (4 s) of the device.^[49] We expect that the response rate can be improved by improving the crystalline quality of 2D NbOI₂ flakes, constructing van der Waals heterojunctions or using surface modification methods.

3. Conclusions

We have successfully prepared 2D NbOI₂ crystal and investigated its in-plane anisotropic properties. ARPES measurements reveal the large anisotropy of phonon vibration modes. Micro-absorbance indicates the bandgaps of NbOI₂ are from 1.7 eV (bulk) to 2.4 eV (monolayer). Moreover, the angle-resolved electrical resistance and photoelectric detection indicate that the anisotropy factor of electrical conductance and photoresponsivity is 1.34 and 1.7, respectively. The in-plane anisotropic optical and electrical properties make NbOI₂ a promising candidate for polarization-sensitive photodetector, synaptic transistors, polarization field-effect transistors, and sensors.^[50–53] In addition, due to the chirality and polarity of NbOI₂, it has broad

application prospects in 2D anisotropic piezoelectric and ferroelectric devices, chiral optical effect, and asymmetric catalysis.

4. Experimental Section

Sample Preparation: High-purity NbOI₂ single crystals were grown through a CVT method. The starting reactants Nb, Nb₂O₅ and I₂ powders in a ratio of 3:1:6 were sealed in an evacuated quartz tube. The tubes were slowly heated up to 700 °C, kept at this temperature for 3 d and cooled to room temperature with the furnace cooling naturally. The products were soaked in alcohol to remove the excess I₂. The harvested crystals were shiny rectangle plates with dimensions of 6 × 8 × 0.5 mm³. The thin NbOI₂ flakes were exfoliated mechanically and transferred onto a SiO₂/Si substrate. The thickness of the 2D NbOI₂ flakes can be confirmed through an optical microscope (Olympus, BX51) and AFM microscopy (Bruker Dimension Fast Scan).

Characterization: The PXRD patterns were measured using a Rigaku-TTR3 X-ray diffractometer with Cu-Kα target at the angle of 5°–60°. The element compositions of NbOI₂ crystal were confirmed through energy dispersive X-ray spectroscopy. The microstructure of the exfoliated 2D NbOI₂ flakes was studied by the high-resolution transmission electron microscopy (JEM-ARM2100F). The temperature-dependent Raman and angle polarization Raman spectra measurements were carried out on a microscope spectrometer, equipped with ×100 optical objective and 1800 grooves mm^{−1} grating. The excitation power and wavelength were 1 mW and 532 nm, respectively. To detect the polarized Raman spectra, the incident laser was polarized, and the scattering light was in the direction parallel and perpendicular to the incident light. The SHG signals were collected in a chameleon femtosecond laser (140 fs, 80 MHz). The optical bandgaps of 2D NbOI₂ flakes with different thicknesses were determined by Jasco MSV-5200 microscopic spectrophotometer.

Device Fabrication and Measurements: The devices based on 2D NbOI₂ flakes were fabricated by using electron-beam lithography (FEI Quanta 650 SEM and Raith Elphy Plus) and the In/Au contact electrodes produced by the thermal evaporation (Nexdep, Angstrom Engineering). The electrical transports of 2D NbOI₂ flakes were performed in a probe station. The angle polarization-resolved photodetection was measured by rotating the angle of polarized laser at 365 nm with a polarizer and a half-wave plate.

Supporting Information

Supporting Information is available from the Wiley Online Library or from the author.

Acknowledgements

Y.F. and F.W. contributed equally to this work. This work was supported financially by the National Natural Science Foundation of China (Grant No. 21825103), the Research Program of the Chinese Academy of Sciences (Grant No. E01YQZ18), and the Shanghai Super Postdoctoral (Grant No. E01SCB19).

Conflict of Interest

The authors declare no conflict of interest.

Data Availability Statement

The data that support the findings of this study are available from the corresponding author upon reasonable request.

Keywords

chiral 2D materials, in-plane anisotropy, NbOI₂

Received: February 22, 2021

Revised: April 5, 2021

Published online: June 6, 2021

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